



ZF-N
Docket No.: M1071.1886
(Patent)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

KUBOTA, MASAHIRO

Application Number: 10/751,444

Confirmation No.: 2577

Application Date: January 6, 2004

Art Unit: n/a

For: PHOTOREACTIVE RESIN COMPOSITION,
METHOD FOR MAKING CIRCUIT SUBSTRATE
USING THE SAME, AND METHOD FOR MAKING
CERAMIC MULTILAYER SUBSTRATE USING THE
SAME

Examiner: Unassigned

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir,

It is respectfully requested that the attorney named below be advised of the status of the above-identified application. Please advise us of when we might expect to receive an Office Action from the Patent and Trademark Office.

Respectfully Submitted,

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Dated: January 26, 2006